

In re Application of:

Xi, et al.

Serial No.: 10/052,681

Confirmation No.: 4083

Filed:

January 17, 2002

For:

Reliability Barrier

Integration for Cu

Application

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

Group Art Unit: 2814

Examiner:

Ginette Peralta

CERTIFICATE OF MAILING

37 CFR 1.8 I hereby certify that this correspondence is being deposited on

as First Class Mail in an envelope addressed to: Commissioner

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9/19/03

Signature

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

The Applicants, and the Attorney who signs below on the basis of the information supplied by the inventor and the information in his file, submit herewith patents, publications, or other information of which they are aware, which may be material to the examination of this application and in respect of which there may be a duty to disclose in accordance with 37 CFR § 1.56.

While the information submitted in this Supplemental Information Disclosure Statement may be material pursuant to 37 CFR § 1.56, it is not intended to constitute an admission that any patent, publication, or other information referred to therein is prior art for this invention unless specifically designated as such.

In accordance with 37 CFR § 1.97, this Supplemental Information Disclosure Statement is not to be construed as a representation that a search has been made or that no other possibly material information as defined under 37 CFR § 1.56(a) exists.

The patents and/or publications submitted herewith are set forth on the attached Form PTO-1449.

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180.00 DA

The Commissioner is hereby authorized to charge the sum of \$180.00 due under 37 CFR § 1.17(p) pursuant to § 1.97, and any other fee necessary to make this submission timely, to the Deposit Account No.: 20-0782/AMAT/1931.P1/KMT.

Respectfully submitted,

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Attorney for Applicant(s)

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U.S. Department of Commerce Patent and Trademark Office					Docket	Docket No.		Serial No.	
(PTO Form 1449 modified) SEP 2 2 2003						AMAT/1931.P1/CPI/ COPPER/PJS		10/052,681	
SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT BY APPLICANT						Applicant Xi, et al.		Confirmation No. 4083	
(Use several sheets if necessary)					Filing D	Filing Date		Group	
Examiner Ginette Peralta					January	/ 17, 2002	2814		
U.S. Pater	nt Docu	ments							
*Examiner Initial		Document Number	Issue Date	Applicant(s) Name	Class	Subclass	_	Filing Date If Appropriate	
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	A2	5,792,272	08/11/1998	Van Os, et al.	118	723 IR	08/12/1997	7	
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Foreign Pa	atent Do	cuments					<u> </u>		
*Examiner		Document	Date	Country	Class	Subclass	Transla	ation	
Initial	ļ	Number					YES	NO	
	B1								
	B2								
	B3								
	B4								
	B5								
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	C1 /	Ghandhi, Sorab K., "VLSI Fabrication Principles, Silicon and Gallium Arsenide" Second Edition, Wiley-Interscience Publication (1994), Pages 617-620 and Page 652.							
	C2								
Examiner					Date Co				
*EXAMINER citation if not	: Initial if in confo	reference conside rmance and not c	ered, whether or no considered. Include	ot citation is in confo e copy of this form w	rmance wit	h MPEP 609; mmunication t	Draw line thro o applicant.	ough	